



RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 2851


03500.015110.1

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:) Examiner: K. C. Gutierrez
	:
Takako YAMAGUCHI et al.) Group Art Unit: 2851
	:
Application No.: 10/630,792) Confirmation No.: 7876
	:
Filed: July 31, 2003)
	: January 20, 2006
For: PATTERN-FORMING APPARATUS)
USING A PHOTOMASK (As Amended)	:

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

*enter
amendment*


AMENDMENT AFTER FINAL REJECTION

Sir:

In response to the final Official Action dated November 25, 2005, please amend the
above-identified application as follows, pursuant to 37 CFR 1.116: